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PATENT

3742

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the U.S. Patent Application of: )

CERTIFICATE OF MAILING

Inventor(s): **Hyoung June KIM** )

**July 29, 2003**

Date of Deposit

Serial No.: **09/886,940** )

Filed: **June 21, 2001** )

Examiner: **Quang T. Van** )

Art Unit: **3742** )

For: **METHODS & APPARATUSES  
FOR HEAT TREATMENT OF  
SEMICONDUCTOR FILMS UPON  
THERMALLY SUSCEPTIBLE  
NON-CONDUCTING  
SUBSTRATES** )

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**RESPONSE TO RESTRICTION REQUIREMENT**

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**TECHNOLOGY CENTER**

In response to the Office Action mailed on May 29, 2003, a response to which is due no later than **September 29, 2003**, Applicants submit the present Election, together with a petition for a one month extension of time pursuant to 37 C.F.R. 1.136(a) and a check in the amount of \$55.00 for the fee set forth in 37 C.F.R. 1.17(a)(1). Please consider the arguments and remarks set forth below, all of which are made without prejudice.

Remarks/Arguments begin on page 2 of this paper.